

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	1430	(CMP or "chemical mechanical polishing") and dummy with pattern	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/07/06 14:07
S2	110	(CMP or "chemical mechanical polishing") and dummy with pattern and mark\$3 with pattern	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/07/06 14:43
S3	368	(CMP or "chemical mechanical polishing") and dummy with pattern and dishing	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/07/06 16:58
S4	5	("4786867"   "5240874"   "6057245"   "6069083"   "6214734").PN. OR ("6475879").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/07/06 16:45
S5	3398	(CMP or "chemical mechanical polishing") and ("defect analysis" or FIB or "focused ion beam" or SEM or "scanning electron microscope")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/07/06 16:59
S6	104	(CMP or "chemical mechanical polishing") and ("defect analysis" or FIB or "focused ion beam" or SEM or "scanning electron microscope") and dummy with pattern	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/07/06 17:36
S7	2	(CMP or "chemical mechanical polishing") and "reference plain"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/07/06 17:36
S8	52	(CMP or "chemical mechanical polishing") and dummy with grid	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/07/06 17:37

## EAST Search History

S9	4	("5308682"   "6020616"   "6255697").PN. OR ("6603162").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/07/06 17:45
S10	0	("2005/0023648").URPN.	USPAT	OR	ON	2006/07/06 17:47